

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ikuo Nishimoto *et al.*
Serial No. : To be assigned
Date of Filing : June 14, 2005
Title : *APPARATUS AND METHOD OF EXPOSING LIGHT TO A
SEMICONDUCTOR DEVICE HAVING A CURVED SURFACE*
Art Unit : To be assigned
Examiner : To be assigned

PRELIMINARY AMENDMENT

MAIL STOP: PCT RO/US

Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination, please amend the above-identified application as set forth below:

Amendments to the Specification: Begin at page 2.

Amendments to the Claims: None.

Remarks: begin on page 3.